

## Application Data Sheet

### Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title ::

SEMICONDUCTOR DEVICE

AND FABRICATING

METHOD THEREOF

Attorney Docket Number::

0756-7217

Total Drawing Sheets::

10

Small Entity?::

No

### Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Given Name::

Akira

Middle Name::

Family Name::

ISHIKAWA

Name Suffix::

City of Residence::

Atsugi

State or Province of Residence::

Kanagawa

Country of Residence::

Japan

Street of mailing address::

c/o Semiconductor Energy

Laboratory Co., Ltd.

398, Hase

City of mailing address:: Atsugi-shi  
State or Province of mailing address:: Kanagawa-ken  
Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: Japan  
Given Name:: Shingo  
Middle Name::  
Family Name:: EGUCHI  
Name Suffix::

City of Residence:: Tochigi  
State or Province of Residence:: Tochigi  
Country of Residence:: Japan  
Street of mailing address:: c/o Semiconductor Energy  
Laboratory Co., Ltd.  
398, Hase

City of mailing address:: Atsugi-shi  
State or Province of mailing address:: Kanagawa-ken  
Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: Japan  
Given Name:: Seiji  
Middle Name::  
Family Name:: ODA

Name Suffix::  
City of Residence:: Kurashiki

State or Province of Residence:: Okayama  
Country of Residence:: Japan  
Street of mailing address:: c/o Sharp Kabushiki Kaisha  
22-22, Nagaike-cho, Abeno-ku  
City of mailing address:: Osaki-shi  
State or Province of mailing address:: Osaki  
Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 545-0013

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: Japan  
Given Name:: Yoshinori  
Middle Name::  
Family Name:: HIGAMI  
Name Suffix::  
City of Residence:: Fukuyama  
State or Province of Residence:: Hiroshima  
Country of Residence:: Japan  
Street of mailing address:: c/o Sharp Kabushiki Kaisha  
22-22, Nagaike-cho, Abeno-ku  
City of mailing address:: Osaki-shi  
State or Province of mailing address:: Osaki  
Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 545-0013

## Correspondence Information

Correspondence Customer Number :: 31780  
E-Mail address:: erobinson@riplo.com

## Representative Information

Representative Customer Number:: 31780

## Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::

## Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2002-320785	11/05/2002	Yes

## Assignee Information

Assignee name:: Semiconductor Energy  
Laboratory Co., Ltd.  
Street of mailing address:: 398 Hase  
City of mailing address:: Atsugi-shi  
State or Province of mailing address:: Kangawa-ken

Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 243-0036

Assignee name:: Sharp Kabushiki Kaisha  
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Country of mailing address:: Japan  
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